



IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

PATENT

112B
FILED
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Applicant: Kumar et al.
Serial No. 09/903,114
Filed: July 11, 2001
For: THERMAL PROCESSING SYSTEM
AND METHODS FOR FORMING
LOW-K DIELECTRIC FILMS
SUITABLE FOR INCORPORATION
INTO MICROELECTRONIC DEVICES

Examiner: B. Talbot
Group Art Unit: 1762
Docket No. FSI0006/US/2

Mail Stop RCE
Commissioner for Patents
P.O. Box 1450
Alexandria, VA 22313-1450

I CERTIFY THAT ON June 30, 2003, THIS PAPER IS
BEING DEPOSITED WITH THE U.S. POSTAL SERVICE AS FIRST
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FOR PATENTS, P.O. BOX 1450, ALEXANDRIA, VA 22313-1450

Paula J. Breeden
PAULA J. BREDEN

SUBMISSION UNDER 37 C.F.R. § 1.114

Introductory Comments

Dear Sir or Madam:

This Submission is being filed concurrently with a Request for Continued Examination under 37 C.F.R. § 1.114 and is fully responsive to the Final Office Action, mailed January 30, 2003, in the above-mentioned application.

Request for Extension of Time

The three-month shortened statutory period for response to the Final Office Action in the above-mentioned application expired on April 30, 2003. Pursuant to 37 CFR 1.136, Applicants hereby request a two-month extension of time to file this Submission and concurrently filed Request for Continued Examination, extending the date for response to June 30, 2003. The fee of \$ 410.00 for the extension of time is enclosed herewith.

The fee of \$ 750.00 for the Request for Continued Examination is enclosed herewith.

It is believed that no additional fee is required in filing this Submission and concurrently filed Request for Continued Examination. However, the Commissioner is authorized to charge any additional fees or credit any overpayment to Kagan Binder Deposit Account No. 50-1775 and notify the undersigned of the same.

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